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DEC-02-2003 11:49

PARKHURST AND WENDEL

703 739 0229 P.01/04

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masaaki KURIHARA et al.

Serial No.: 10/614,345

Filed: July 8, 2003

For: PHASE MASK FOR FORMING DIFFRACTION GRATING,  
METHOD OF FABRICATING PHASE MASK AND METHOD  
FOR FORMING DIFFRACTION GRATING

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents  
Office of Initial Patent Examination  
Filing Receipt Corrections - Fax No.: 703-746-9195  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Serial No.: 10/614,345

Sir:

A corrected filing receipt is hereby requested in view of the error which appears in the original. For the convenience of the Patent and Trademark Office, attached is a photocopy of the original receipt on which the errors have been noted in red.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

Date: December 2, 2003

  
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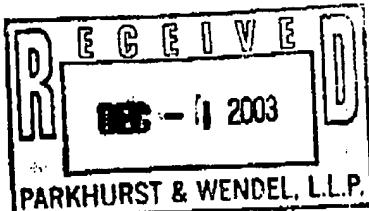


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/614,345	07/08/2003		1288	DAIN:740	5	14	+6

6160  
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 ALEXANDRIA, VA 22314-2805



## CONFIRMATION NO. 7853

## FILING RECEIPT



\*OC00000011359800\*

Date Mailed: 11/26/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

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**Assignment For Published Patent Application**

Dai Nippon Printing Co., Ltd., Shinjuku-Ku, JAPAN;

**Domestic Priority data as claimed by applicant****Foreign Applications**

JAPAN 2002-200558 07/09/2002

If Required, Foreign Filing License Granted: 11/25/2003

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

**Title**

Phase mask for forming diffraction grating, method of fabricating phase mask, and method of

forming diffraction grating

**Preliminary Class**

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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